



PATENT
8017-1127

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Takahiro ADACHI et al. Conf. 9125

Application No. 10/774,462 Group 2816

Filed February 10, 2004 Examiner Unassigned

CIRCUIT AND METHOD FOR COMPENSATING
FOR NONLINER DISTORTION OF POWER AMPLIFIER

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the accompanying document, a copy of which is attached to this statement, is made of record on the enclosed Form PTO-1449.

A concise explanation of the relevance of this reference is that this reference was cited by the Chinese Patent Office in the corresponding Chinese Application Serial No. 200410004393.X. A copy of the Chinese Official Action in which it was cited is attached hereto. **An English translation of the Chinese Official Action is also attached hereto.**

Under the provisions of 37 CFR 1.97(e), the undersigned hereby certifies that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign Patent Office in a

counterpart foreign application not more than three months prior to the filing of this Statement.

Respectfully submitted,

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INFORMATION DISCLOSURE CITATION IN AN APPLICATION		Attorney Docket No.: 8017-1127		Application No.: 10/774,462		
(Use several sheets if necessary)		Applicant: Takahiro ADACHI et al.				
		Filing Date: February 10, 2004		Group Art Unit: 2816		
U.S. PATENT DOCUMENTS						
Examiner Initial	Document Number	Date	Name	Class	Subclass	
<i>(Large empty table area for U.S. Patent Documents)</i>						
FOREIGN PATENT DOCUMENTS						
Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation
	JP 10-322137	12/4/1998	Japan (with English abstract)			Yes No
<i>(Large empty table area for Foreign Patent Documents)</i>						
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
<i>(Large empty table area for Other Documents)</i>						
EXAMINER:		DATE CONSIDERED				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						

* Abstract provided for the Examiner's convenience